

# राष्ट्रीयप्रौद्योगिकीसंस्थानसिलचर National Institute of Technology Silchar

(राष्ट्रीय महत्व का संस्थान)

#### (An Institute of National Importance)

www.nits.ac.in, Phone: 03842-242914, Fax: 03842-224797, Assam-788010 (INDIA)

Date: 08.10.2020

Advertisement No.: NITS/Dean(R&C)/ME/548/01/2020

Applications are invited from Indian citizens for a temporary of post of <u>Junior Research Fellow (JRF)</u> for the <u>CSIR EMR-II</u> sponsored project in the Department of Mechanical Engineering NIT Silchar.

Title of the project	Design and Development of a High Speed Three Dimensional Pinter			
	with a Large Range of Micro Motion using a Scanning Stereo-			
	lithography Technique			
Sponsored Agency	CSIR EMR-II			
Project sanction number	22(0831)/19/EMR-II dated 02.12.2019			
No. of posts	01			
Duration	03 years			
Principal Investigator (P.I)	Dr. Yogesh Singh			

#### General Information and Terms & Conditions

1.	Age Limit	28 years
2.	Essential Qualification	M.E., M. Tech or equivalent degree in Mechanical Engineering /
		Technology stream alongwith GATE/NET qualification.
3.	Desirable Qualification	Master Degree in Design and Manufacturing Engineering/CAD-CAM
		and Automation/ Manufacturing Engineering with research experience
		in the field of robotics, compliant mechanism and mechatronics
4.	Salary	Rs. 31,000/- per month
5.	Relaxation on qualification and	SC/ST/OBC/WOMEN/PWD/EWS candidates will get
	age	relaxation as per Govt of India Rules.
6.	Last date of receiving/ submission	03.11.2020
	of filled up application form	
7.	Reporting	Applicants are requested to submit their filled-up applications along
		with C.V. to the P.I. accompanying photocopies of all documents.
		Applicants are also requested to send the soft copy of the duly filled
		application along with C.V. & all necessary documents to the P.I
		through email ( <u>yogesh@mech.nits.ac.in</u> ) on or before 03.11.2020.
8.	Date of interview, time, and venue	23.11.2020, 11.00 AM, Department of Mechanical Engineering, NIT
		Silchar
9.	No objection certificate	Employed candidates are to submit no objection certificate from
1.0		his/her employer at the time of interview.
10.	Institute right	The Institute has the discretion to restrict the number of candidates to
		be called for the interview on the basis of screening. No candidate
1.1	G: : 6.1	may be recruited if suitable candidates are not found.
11.	Signing of the agreement	Selected candidates shall have to sign an agreement at the time of
		joining.

# National Institute of Technology Silchar

### FORMAT of APPLICATION

# for Junior Research Fellow

Paste recent passport size colored photograph

1.	Advertisement no	dated:				
2.	Title of the Project					
3.	Department:					
4.	Name of the applicant	(in block letters):				
5.	Father's/Husband's Na	ame:				
	Date of Birth (DD-MM-					
7.	Age as on 03 <sup>rd</sup> Nov, 2020:					
8.	Postal Address:					
	E-mail:	Phone no.:				
9.	Permanent Address:					
10.	Nationality:					
11.	Marital Status:					
12.	Whether belongs to SC	/ST/ OBC/PwD/EWS: (If yes, attach certificate):				
13.	Educational Qualificati	on: (Starting from Class X)				

Exam. passed	Board/ University	Divi sion	% age of marks / CPI	Year of passing	Subjects

14. NET/GATE Examinations Passed	d:
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II. GATE	Γ	I. NE	
lid upto Subject Score Valid upto	Valid upto	Qualifying date	Subject
lid upto Subject Score Vali	Valid upto	Qualifying date	Subject

## 15. Details of employments:

S1. No.	Name of the Organization	Name of the post	Period	Scale of pay and present pay	Nature of duty

16. Any other relevant information that you may like to furnish:

### Declaration

]	I declare	that the a	bove info	rmation a	are true a	and corre	ect to the	best of	f my
knowle	edge and	belief.							

Date:	
Place	Signature of the applicant